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Harold C. Moore

Name of person mailing Document or Fee

Signature

June 1, 2005

Date of Signature

Re: Application of: Tilke et al.
Serial No.: 10/780,276
Filed: February 17, 2004
For: Semiconductor Structure with Increased
Breakdown Voltage and Method for
Producing the Semiconductor Structure
Group Art Unit: 2811
Confirmation No.: 7063
Examiner: Thien F. Tran
Our Docket No.: 1890-0061

SUBMISSION OF PRIORITY DOCUMENT

Please find for filing in connection with the above patent application a certified copy of the priority document, Certified Copy of German Application Number 103 06 597.0.

DOCKETED
6/11/05 Dm

Commission for Patents
June 1, 2005
Page 2

Please charge any fee deficiency or credit any overpayment to Deposit Account
No. 13-0014.

Respectfully submitted,



June 1, 2005

Harold C. Moore
Registration No. 37,892
Maginot, Moore & Beck
Bank One Center/Tower
111 Monument Circle, Suite 3000
Indianapolis, IN 46204-5115

Enclosures